



#6/9-602
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re PATENT APPLICATION of

MIYASHITA et al.

Group Art Unit: 2815

Appln. No.: 09/916,530

Examiner: George C. Eckert II

Filed: July 30, 2001

Title: SEMICONDUCTOR DEVICE COMPRISING
METAL SILICIDE FILMS FORMED TO COVER
GATE ELECTRODE AND SOURCE-DRAIN
DIFFUSION LAYERS AND METHOD OF
MANUFACTURING THE SAME

TECHNOLOGY CENTER 2800

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August 23, 2002

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents
Washington, D.C. 20231

Sir:

I hereby certify that each enclosed document listed on the attached Form PTO-1449 was cited in the attached Japanese Office Action, June 11, 2002, issued in a foreign counterpart application. See the degree of relevancy (category) and the particular passages cited for each document in that Office Action.

Contingent Petition Under Rule 97(d): Should a Final Rejection have been issued before the filing date of this Information Disclosure Statement, please consider this a Petition under Rule 97(d)(ii), charge the petition fee to our Deposit Account No. 03-3975 under Order No. 008312/0279038 , and proceed to consider this Information Disclosure Statement under Rule 97(d).

This Information Disclosure Statement is intended to be in full compliance with the rules, but should the Examiner find any part of its required content to have been omitted,

Appln. No.: 09/916,530 - MIYASHITA et al.

~~prompt~~ notice to that effect is earnestly solicited, along with additional time under Rule 97(f), to enable Applicant to comply fully.

Consideration of the foregoing and enclosures plus the return of a copy of the enclosed Form PTO-1449 with the Examiner's initials in the left column per MPEP 609 along with an early action on the merits of this application are earnestly solicited.

Respectfully submitted,

PILLSBURY WINTHROP LLP

By



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Client Ref.

279038

T1HM-98S0740-D

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Applicant: Miyashita et al.

Appln. No.: 09/916,530

Filing Date: July 30, 2001

Date: August 23, 2002

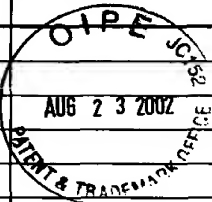
Page 1 of 1

Examiner: G. C. Eckert II

Group Art Unit: 2815

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR					
	BR					
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FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name		Abstract		Readily Available	
							Enclosed	No	Enclose	No
	OR	09-64349 /	03/1997	Japan			yes			
	PR	7-74128 //	03/1995	Japan				x		
	QR	10-135152 //	05/1998	Japan			yes			
	RR	1-133368 //	05/1989	Japan				x		
	SR	4-230030 //	08/1992	Japan			yes			
	TR	62-66679 /	03/1987	Japan			yes			
	UR	3-209834 /	09/1991	Japan			yes			
	VR	8-330254 //	12/1996	Japan				x		
	WR									
	XR									

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

	YR						
	ZR						
	AAR						
	BBR						
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Examiner

Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.